

(19) World Intellectual Property  
Organization  
International Bureau



(43) International Publication Date  
17 March 2005 (17.03.2005)

PCT

(10) International Publication Number  
**WO 2005/024088 A2**

(51) International Patent Classification<sup>7</sup>: **C23C 14/22,**  
14/56

(21) International Application Number:  
PCT/IB2004/002960

(22) International Filing Date:  
10 September 2004 (10.09.2004)

(25) Filing Language: Italian

(26) Publication Language: English

(30) Priority Data:  
TO2003A000690  
11 September 2003 (11.09.2003) IT

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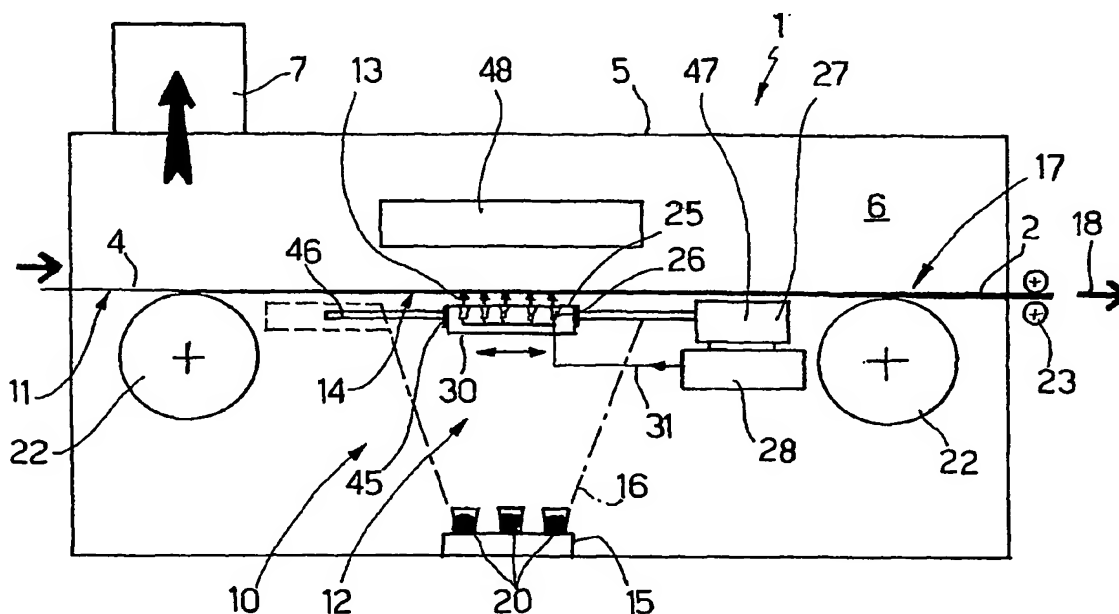
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(81) Designated States (unless otherwise indicated, for every  
kind of national protection available): AE, AG, AL, AM,  
AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN,  
CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI,  
GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE,  
KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD,  
MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG,  
PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM,  
TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM,  
ZW.

(84) Designated States (unless otherwise indicated, for every  
kind of regional protection available): ARIPO (BW, GH,

[Continued on next page]

(54) Title: A METHOD AND EQUIPMENT FOR DEPOSITION OF FILMS OF COATING MATERIALS, IN PARTICULAR  
SUPERCONDUCTIVE OXIDES



(57) Abstract: There are provided herein a method and an apparatus for deposition of films of coating materials on a substrate, of particular use in obtaining superconductive composite tapes for deposition of films of superconductive oxides and/or buffer layers. A step of deposition of the film (2) on the substrate (4) is associated to a step of gas treatment in situ, in which a flow (13) of gas is sent towards a working surface (14) of the substrate or of the film growing on the substrate. The gas-treatment step is performed via ultrasound expansion nozzles (26).



GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

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**Published:**

- *without international search report and to be republished upon receipt of that report*

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